Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
S1	4	(("6249370") or ("6549694") or ("6639722") or ("6002154")).PN.	USPAT; USOCR	OR	OFF	2008/01/16 19:15
S2	o	S1 and pzt	USPAT	OR	OFF	2008/01/16 19:15
S3	100745	actuator\$1 and ((height\$1 or position\$1) with (var\$4 or differ\$4))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/01/16 19:15
S4	101	wavefront adj pattern\$1	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/01/16 19:15
S5	1	S1 and (zirconate with titanate)	USPAT	OR	OFF	2008/01/16 19:15
S6		modulator and (insulat\$3 with layer\$1 with substrate\$1 with dissipat\$3 with heat\$3 with electrode\$1)	US-PGPUB; USPAT	OR	OFF	2008/01/16 19:15
S7	24512	actuator\$1 same ((height\$1 or position\$1) with (var\$4 or differ\$4))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/01/16 19:15
S8	17840	diffract\$3 with refract\$3	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/01/16 19:15
S9	1	("6249370").PN.	USPAT; USOCR	OR	OFF	2008/01/16 19:15
S10	0	S9 and pzt	USPAT	OR	OFF	2008/01/16 19:15
S11	677	(first with order with diffraction with second) and "359"/\$.ccls.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/01/16 19:15
S12	91	(insulat\$3 with layer\$1 with substrate\$1 with dissipat\$3 with heat\$3 with electrode\$1)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/01/16 19:15
S13	1	"20050046921"	US-PGPUB; USPAT	OR	OFF	2008/01/16 19:15
S14	1	S13 and pzt	US-PGPUB; USPAT	OR	OFF	2008/01/16 19:15

			· · · · · · · · · · · · · · · · · · ·			
S15	1	"20050046921"	US-PGPUB; USPAT	OR	OFF	2008/01/16 19:15
S16	0	S15 and (two with dimension\$2 with array\$1)	US-PGPUB; USPAT	OR	OFF	2008/01/16 19:15
S17	0	S15 and (two with dimension\$2)	US-PGPUB; USPAT	OR	OFF	2008/01/16 19:15
S18	13915	actuator\$1 with ((height\$1 or position\$1) with (var\$4 or differ\$4))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/01/16 19:15
S19	647	actuator\$1 with (height\$1 with differ\$4)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/01/16 19:15
S20	82	modulator\$1 and (benedicto)	US-PGPUB; USPAT	OR	OFF	2008/01/16 19:15
S21	1	S9 and zirconate	USPAT	OR	OFF	2008/01/16 19:15
S22	447	actuator\$1 with (height\$1 with different)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/01/16 19:15
S23	2699	(359/290,291,295,571).CCLS.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR .	OFF	2008/01/16 19:15
S24	1245	diffract\$3 with refract\$3 with mirror\$1	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/01/16 19:15
S25	300	diffract\$4 with quarter with wavelength\$1	USPAT	OR	OFF	2008/01/16 19:15
S26	406	((first with order with diffraction with second) and "359"/\$.ccls.) and mirror\$1	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/01/16 19:15
S27	366	(actuator\$1 same electrode\$1 same (reflect\$3 or mirror\$1)) and (((359/290,291,295,571).CCLS.) or ((385/18).CCLS.))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/01/16 19:15

		<u> </u>				
S28	366	(actuator\$1 same electrode\$1 same (reflect\$3 or mirror\$1)) and (((359/290,291,295,571).CCLS.) or ((385/18).CCLS.))	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/01/16 19:15
S29	0	(PZT or zirconate) with contract\$3 with expand\$3 with spatial	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/01/16 19:15
S30	0	((PZT or zirconate) with contract\$3 with expand\$3) same spatial	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/01/16 19:15
S31	1	"20050046921"	US-PGPUB; USPAT	OR	OFF	2008/01/16 19:15
S32	0	S31 and (individual\$2 with modulat\$3)	US-PGPUB; USPAT	OR	OFF	2008/01/16 19:15
S33	2459	modulator\$1 same (individual\$5 with control\$4)	US-PGPUB; USPAT	OR	OFF	2008/01/16 19:15
\$34	99	(PZT or zirconate) with actuator with (contract\$3 or expand\$3)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/01/16 19:15
S35	1708	(385/18).CCLS.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/01/16 19:15
S36	4293	((359/290,291,295,571).CCLS.) or ((385/18).CCLS.)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/01/16 19:15
S37	1984	(PZT or zirconate) with actuator	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/01/16 19:15
S38	1	("6249370").PN.	USPAT; USOCR	OR	OFF	2008/01/16 19:15
S39	0	S38 and pzt	USPAT	OR	OFF	2008/01/16 19:15
S40	0	S38 and plzt	USPAT	OR	OFF	2008/01/16 19:15
S41	1255	modulator\$1 with individual\$5 with control\$4	US-PGPUB; USPAT	OR	OFF	2008/01/16 19:15

				г		
S42	89	modulator\$1 same (reflect\$3 with curve)	US-PGPUB; USPAT	OR	OFF	2008/01/16 19:15
S43	293	(jack with dinh)	US-PGPUB; USPAT	OR	OFF	2008/01/16 19:15
S44	63	(insulat\$3 with layer\$1) with substrate\$1 with dissipat\$3 with heat\$3 with electrode\$1	US-PGPUB; USPAT	OR	OFF	2008/01/16 19:15
S45	0	modulator and (insulat\$3 with layer\$1 with substrate\$1 with dissipat\$3 with heat\$3 with electrode\$1)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/01/16 19:15
S46	4293	((359/290,291,295,571).CCLS.) or ((385/18).CCLS.)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/01/16 19:15
S47	1	S15 and (four with direction\$1)	US-PGPUB; USPAT	OR	OFF	2008/01/16 19:15
S48	1	S15 and (two)	US-PGPUB; USPAT	OR	OFF	2008/01/16 19:15
S49	1	("6,549,694").PN.	USPAT; USOCR	OR	OFF	2008/01/16 19:15
S50	1	S13 and piston\$	US-PGPUB; USPAT	OR	OFF	2008/01/16 19:15
S51	1	S15 and (four)	US-PGPUB; USPAT	OR	OFF	2008/01/16 19:15
S52	. 0	S15 and (dimension\$2)	US-PGPUB; USPAT	OR	OFF	2008/01/16 19:15
S53	1	S13 and (insulating with layer\$1)	US-PGPUB; USPAT	OR	OFF	2008/01/16 19:15
S54	1	S43 and ((one with two with degree\$1).clm.)	US-PGPUB; USPAT	OR .	OFF	2008/01/16 19:15
S55	1	S31 and (individual\$2)	US-PGPUB; USPAT	OR	OFF	2008/01/16 19:15
S56	1	("6856449").PN.	USPAT; USOCR	OR	OFF	2008/01/16 19:15
S57	13	((method or process) with (form\$3 or mak\$3) with (spatial with modulator\$1)).ti.	US-PGPUB; USPAT	OR	OFF	2008/01/16 19:15
S58	1	S31 and wavefront	US-PGPUB; USPAT	OR	OFF	2008/01/16 19:15
S59	1	S31 and wavefront\$1	US-PGPUB; USPAT	OR	OFF	2008/01/16 19:15

S60	12	((actuator\$1 or reflect\$3 or mirror\$1) with (height\$1 with different) with pattern\$1) and "359"/\$.ccls.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/01/16 19:15
S61	33	((method or process) with (us\$3) with (spatial with modulator\$1)).ti.	US-PGPUB; USPAT	OR	OFF	2008/01/16 19:15
S62	33	actuator\$1 same ((height\$1 or position\$1) with (var\$4 or differ\$4)) same wavefront\$1	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/01/16 19:15
S63	46	(spatial adj (light\$1 or modulator\$1)) same actuator\$1 same electrode\$1	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR .	OFF	2008/01/16 19:15
S64	35	(wavefront adj pattern\$1) and actuator\$1	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/01/16 19:15
S65	8	actuator\$1 with (height\$1 with different) with pattern\$1	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/01/16 19:15
S66	97	diffract\$3 with refract\$3 with mirror\$1 with wavelength\$1	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/01/16 19:15
S67	27	(diffract\$3 with refract\$3 with mirror\$1 with wavelength\$1) and "359"/\$.ccls.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/01/16 19:15
S68	49	diffract\$4 with quarter with wavelength\$1 with mirror\$1	USPAT	OR	OFF	2008/01/16 19:15
S69	3	(("5735026") or ("5862002") or ("6059416")).PN.	USPAT; USOCR	OR	OFF	2008/01/16 19:15
S70	45	(PZT or zirconate) with actuator with (contract\$3 with expand\$3)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/01/16 19:15

			-			
S71	7	((PZT or zirconate) with contract\$3 with expand\$3) same (modulator\$1)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/01/16 19:15
S72	3	S33 and (jack with dinh)	US-PGPUB; USPAT	OR	OFF ·	2008/01/16 19:15
S73	3	S41 and (jack with dinh)	US-PGPUB; USPAT	OR	OFF	2008/01/16 19:15
S74	72	modulator\$1 and (jack with dinh)	US-PGPUB; USPAT	OR	OFF	2008/01/16 19:15
S75	28	modulator\$1 with (reflect\$3 with curve)	US-PGPUB; USPAT	OR	OFF	2008/01/16 19:15
S76	29	modulator\$1 with (curve\$1 adj mirror\$1)	US-PGPUB; USPAT	OR	OFF	2008/01/16 19:15
S77	21	(insulating adj layer\$1) with substrate\$1 with dissipat\$3 with heat\$3 with electrode\$1	US-PGPUB; USPAT	OR ·	OFF	2008/01/16 19:15
S78	51	S12 and @ad<="20030829"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/01/16 19:15
S79	31	S44 and @ad<="20030829"	US-PGPUB; USPAT	OR	OFF	2008/01/16 19:15
S80	31	S12 and @ad<="20030829"	US-PGPUB; USPAT	OR	OFF	2008/01/16 19:15
S81	185	(actuator\$1 same electrode\$1 same (reflect\$3 or mirror\$1)) and 359/291.ccls.	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/01/16 19:15
S82	236	(actuator\$1 or reflect\$3 or mirror\$1) with (height\$1 with different) with pattern\$1	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/01/16 19:15
S83	113	(359/323).CCLS.	USPAT; USOCR	OR	OFF	2008/01/16 19:27
S84	273	((first with order with diffraction with second) and "359"/\$.ccls.) and mirror\$1	USPAT	OR	OFF	2008/01/16 19:15
S85	1372	S46 and @pd>="20050701"	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2008/01/16 19:15

S86	1507	(359/223,224).CCLS.	USPAT; USOCR	OR	OFF	2008/01/16 19:36
S87	470	(359/320,322,323).CCLS.	USPAT; USOCR	OR	OFF	2008/01/16 19:28

1/16/08 7:40:16 PM C:\Documents and Settings\jdinh\My Documents\EAST\Workspaces\Case 10651048.wsp

Page 7

INTERFERENCE EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	17230	(modulator\$1).clm.	US-PGPUB	OR	OFF	2008/01/16 19:39
L2	59	(modulator\$1 with wavefront\$1). clm.	US-PGPUB	OR	OFF	2008/01/16 19:39
L3	2	(modulator\$1 with wavefront\$1 with substrate\$1).clm.	US-PGPUB	OR	OFF	2008/01/16 19:39
L4	0	(modulator\$1 with wavefront\$1 with substrate\$1 with electrode\$1).clm.	US-PGPUB	OR	OFF	2008/01/16 19:39

1/16/08 7:40:11 PM C:\Documents and Settings\jdinh\My Documents\EAST\Workspaces\Case 10651048.wsp Page 1 EAST Search Results Case No. 10/651,048

s case No. I		
USPAT	Method for the manufacture of an	29/25.35
	electrodisplacive actuator array	
USPAT	Electrostrictive actuated mirror array and method	359/846
	for the manufacture thereof	
US-PGPUB	Optical systems comprising curved MEMs mirrors	385/47
	and methods for making same	
USPAT	PZT fiber optic modulator having a robust	385/12
	mounting and method of making same	
USPAT	Exposure device and method for compensating	355/67
	optical defects	
USPAT	Display device	359/291
USPAT	Actuated mirror array and method for the	359/850
	fabricating thereof	
USPAT	Ultra-high resolution light modulation control	359/298
	system and method	
USPAT	Light modulation device and system	359/290
USPAT	High-frequency MOSFET	257/349
USPAT	Optical switching element, switching apparatus	385/18
ļ	and image display apparatus using optical	
	switching element	
USPAT	Method for using a spatial light modulator	345/84
USPAT	Integrated driver for use in display systems	345/108
	having micromirrors	
US-PGPUB	Spatial light modulator using an integrated circuit	359/291
	actuator and method of making and using same	
USPAT	Stress tuned blazed grating light valve	359/571
USPAT	Detunable Fabry-Perot interferometer and an	359/238
	add/drop multiplexer using the same	,
USPAT	Micromirror array having adjustable mirror angles	359/291
USPAT	Compliant mechanism and method of forming	359/290
	same	
USPAT	Method for forming a ferroelectric liquid crystal	216/23
	spatial light modulator utilizing a planarization	
1	process	
	USPAT	electrodisplacive actuator array USPAT Electrostrictive actuated mirror array and method for the manufacture thereof US-PGPUB Optical systems comprising curved MEMs mirrors and methods for making same USPAT PZT fiber optic modulator having a robust mounting and method of making same USPAT Exposure device and method for compensating optical defects USPAT Display device USPAT Actuated mirror array and method for the fabricating thereof USPAT Ultra-high resolution light modulation control system and method USPAT Light modulation device and system USPAT High-frequency MOSFET USPAT Optical switching element, switching apparatus and image display apparatus using optical switching element USPAT Method for using a spatial light modulator USPAT Integrated driver for use in display systems having micromirrors US-PGPUB Spatial light modulator using an integrated circuit actuator and method of making and using same USPAT Stress tuned blazed grating light valve USPAT Detunable Fabry-Perot interferometer and an add/drop multiplexer using the same USPAT Micromirror array having adjustable mirror angles USPAT Compliant mechanism and method of forming same USPAT Method for forming a ferroelectric liquid crystal spatial light modulator utilizing a planarization

NPL SEARCH HISTORY

Dial	gD	atas	Star
------	----	------	------

options logoff feedback help

databases

Advanced Search:

Inspec - 1898 to date (INZZ)

limit

Search history:

No.	Database	Search term	Info added since	Results	
СР		[Clipboard]		0	-
1	INZZ	modulat\$3 SAME wavefront\$1	unrestricted	760	show titles
2	IN//	modulat\$3 SAME wavefront\$1 SAME actuator\$1 SAME electrode\$1	unrestricted	0	-

hide | delete all search steps... | delete individual search steps...

	whole document		
Information added since: or: none (YYYYMMDD)			search
☐ Images			
Click to select terms from the following list(s):			
Publication year 1950-			
Publication year 1898-1949			
Inspec thesaurus - enter a term			
Classification codes A: Physics, 0-1	•	•	
Classification codes A: Physics, 2-3			
Classification codes A: Physics, 4-5			
Classification codes A: Physics, 6			
Classification codes A: Physics, 7	·		
Classification codes A: Physics, 8			
Classification codes A: Physics, 9			
Classification codes B: Electrical & Electronics, 0-	5		